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Bib Data Sheet

CONFIRMATION NO. 7575

SERIAL NUMBER 09/724,403	FILING OR 371(c) DATE 11/27/2000 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 07977/258001/US4448
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APPLICANTS

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** CONTINUING DATA *****None & W.S.,

** FOREIGN APPLICATIONS *****S.W.S.
JAPAN 11-336850 11/26/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/26/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <u>S.W.S.</u> Initials: _____	STATE OR COUNTRY JAPAN	SHEETS DRAWING 27	TOTAL CLAIMS 43	INDEPENDENT CLAIMS 14
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ADDRESS

26171

S.W.S.
10-6-06

TITLE Method of Manufacturing a Semiconductor Device that Includes Forming a Material with a High Tensile Stress in Contact with a Semiconductor Film to Getter Semiconductor device and method of manufacturing the same Impurities from the Semiconductor Film

FILING FEE RECEIVED 3510	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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